

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/685,138	LEE, JU-HEON	
Examiner	Art Unit	_
Tanh Q. Nguyen	2182	

Date	Examiner

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	1				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Consult brian Johnson on restriction	06/22/06	Tan		
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